

Hi-Dow Electron Technology (Hefei) Inc., Ltd.

U.S. Agent Designation for Service of Process -
Certification Attestation Letter

2/7/2023

Nemko North America, Inc.
303 River Road
Ottawa
K1V 1H2
Canada

ATTN.: Reviewing Engineer

FCC ID: 2ACD4HD-19A

Per section 2.911(d)(7) of the FCC rules, (Hi-Dow Electron Technology (Hefei) Inc., Ltd.) certifies that the equipment for which authorization is sought is designated to the following U.S. agent* for service of process:

Company Name: Hi-Dow International Inc.
Physical U.S. Company Address: 2555 Metro Blvd., Maryland Heights, MO 63043
Agent name: Eric Chen
Agent Email Address: eric@hidow.com
FRN: 0033404187

The above contact person accepts the obligation for service of process.

The applicant accepts to maintain an agent for no less than one year after the grantee has terminated all marketing and importation or the conclusion of any Commission-related proceeding involving the equipment.

Applicant Signed:

Signed: *Yang Chen*
Printed name: : Yang Chen
Title: -
Company Name: Hi-Dow Electron Technology (Hefei) Inc., Ltd.
Date: 2/7/2023

Agent Signed (if different to Applicant):

Signed: *Eric Chen*
Printed name: Eric Chen
Title: CEO
Company Name: Hi-Dow International Inc.
Date: 2/7/2023

* the applicant must designate a contact located in the United States for purposes of acting as the applicant's agent for service of process, regardless of whether the applicant is a domestic or foreign entity. An applicant located in the United States may designate itself as the agent for service of process.